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Complete if Known 10/823,098 Filing Date 04/13/04 First Named Inventor Kowang Liu et al. Art Unit 3744 **Examiner Name** L.V. Ciric Attorney Docket Number HT03-026CC

		NON PATENT LITERATURE DOCUMENTS		
Examiner Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
/LC/	1	"Thermal Conductivity of AIN and SiC Thin Films," by SUN ROCK CHOI ET AL., International Journal of Thermophysics, ISSN 0195-928X, 2006,		
		Vol. 27, No. 3. pp. 896-905, Springer, New York, NY.		
	2	"Measurement of the thermal conductivity of TiO2 thin films by using the thermo-reflectance method," by JUNGHO MUN ET AL., ScienceDirect -		
		Thermochimica Acta, Vol. 455, Issues 1-2, April 1, 2007, http://www.sciencedirect.com/science?_ob=ArticleURL&_udi=B6THV-4		
	3	"Thermal conductivity measurements on thin films based on micromechanical devices," by E. JANSEN ET AL., Journal of Micromechanics		
		and Microengineering, Vol. 6, 1996, http://www.iop.org/EJ/abstract/ 0960-1317/6/1/029.		
	4	"Electrical properties," and "Thermal conductivity," page 5 of 9, found: http://en.wikipedia.org/wiki/Material_properties_of_diamond#Thermal_conductivity,		
/LC/		Material properties of diamond - Wikipedia, the free encyclopedia, 1/18/09.		

Examiner Signature	/Ljiljana Ciric/ (08/31/2009)	Date Considered	08/31/2009

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